IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re U.S. Patent Application of	)	
	)	
OSHIMA *et al.*	)	
	)	
Application Number: 09/987,914	)	
	)	**Art Unit 2814**
Filed: November 16, 2001	)	
	)	
For: SEMICONDUCTOR DEVICE AND ITS FABRICATION	)	

Honorable Assistant Commissioner
for Patents
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Sir:

Pursuant to 37 C.F.R. §§ 1.56 and 1.97, this Information Disclosure Statement is submitted in the above-identified patent application. A listing of documents to be published on the face of any patent granted from this application is submitted herewith on Form PTO-1449. Any other documents or information submitted for consideration by the Examiner are listed in this paper. A copy of each U.S. and foreign patent, or each publication or portion thereof listed or herein identified, is submitted herewith.

This Information Disclosure Statement is being submitted within three months of the initial application. Accordingly, no fee is due or payable at this time.

The Examiner is requested to acknowledge consideration of the information provided in this paper in accordance with prescribed procedures.

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